CLEANING AND SURFACE PROPERTIES M.Taborelli, CERN



Introduction

Methods of precision cleaning for UHV applications

Evaluation of cleanliness and quality control

How clean can we clean?

Packaging and storage





The definition of cleanliness depends on the application

- UHV, beams \rightarrow avoid interaction of gas with particle beam Thin films \rightarrow ensure adhesion of coatings
 - NB: Classical cleaning > 1 μ g/cm² contamination Precision cleaning <1 μ g/cm² (< 3x10¹⁵ molec/cm² of C₁₂H₁₄)

Particle (dust) contamination:

- not considered in the following
- is relevant in some cases for accelerators:
 - -for UFOs (LHC) the relevant size is above 20-50 um (Z dependent)
 - -for RF accelerating cavities related to field emission: particles are removed by high pressure water rinsing and clean room handling is mandatory
 - (-particles down to small diameter, 100 nm, are relevant in semiconductor manufacturing)

Some of the relevant surface contaminations are:





- Adsorbed heavy hydrocarbons (cutting oils, lubricants, markers inks, glue, fingerprints): induce static and dynamic outgassing, hinder coatings adhesion (have low surface energy)
- Adsorbed "intermediate vapour-pressure" compounds: provoke long lasting static outgassing (alcanes: C_{16} Pvap= 10⁻³ mbar, C_{21} 10⁻⁶ mbar, C_{26} 10⁻¹⁰ mbar)
- Other elements/compounds:
 - corrosion inducing elements and compounds (halogens, sulphur....), metals with high pvap (Cd, Zn 10⁻⁷ and 10⁻⁹ mbar at 100C, in platings and brazings), silicone oils and greases (outgassing, insulating layer of SiO₂ deposits on electrical contacts upon irradiation)



Principle : Solvation: balance of entropy (\rightarrow diffusion) and molecular interaction strength for solute-solute (\rightarrow precipitation), which must not be too strong compared to solute-solvent



Solvent degreasing procedures

By immersion: (as in ethanol...) Dip the piece to be cleaned in the solvent bath (proper temperature and time) with ultrasonic agitation. Final rinsing with pure solvent and drying by evaporation.

Without immersion (vapour degreasing):
-Heat the bath of solvent to get vapour
-Keep the cold workpiece above the bath to condense the solvent on it
-Collect the condensed liquid with dissolved contamination dropping from the workpiece in a continuously recycled bath

Combination with co-solvent To extend the range of solvated materials







Vapour degreasing:

- 😳 the solvent is continuously distilled and purified
- 😳 often used as pre-cleaning
- 🙁 needs adapted closed plant to avoid loss of solvent (safety and environment)

Solvents are better for parts with complex shapes (bellows), porous materials (ceramics, composites...) which cannot be easily rinsed or dried, and cannot sustain aqueous cleaning....with some limitations...

Solvent solubility and cleaning efficiency are contaminant dependent ("like with like")

Ex: CO_2 , hydrofluoroethers C_nF_{2n+1} -O- C_mH_{2m+1} , modified alcohols (having polar and non polar components R'-O-R"-OH), hydrofluoro/chloro carbons with zero ozone depletion potential, but **GWP**.... M.Taborelli, CAS-Lund, June 2017



Water based cleaning: detergents



Principle: a detergent can wet any surface (surfactant: reduces the surface energy of the liquid): amphiphilic molecule with polar head and non-polar tail, soluble in water and organic solvents, can incorporate the non-polar hydrophobic material which can thus be dissolved (formation of micelles) and cannot be redeposited on the surface.



Detergent cleaning procedure

water and detergent bath (surfactants, builders)

T (typically 50°-60°C) ultrasonic agitation (or turbulent flow for long pipes which cannot be immersed)

rinsing with demineralized or tap water stream or ultrasound

rinsing with demineralized water bath (conductivity $<5 \ \mu S \ cm^{-1}$) NB: the first effective control is a verification of wetting of the surface by the rinsing water

Drying in oven 80°-100°C (possible for small parts only and suitable materials) or dry nitrogen (filtered) or spreading ethanol









generally used for non-porous materials and parts of simple shape, which can be properly rinsed/dried

PH is basic (~9.6 for the CERN bath), surface oxides and some alloys (Ag/Cu brazing, NEG, Al, alloys...) can be slightly etched; test for your workpiece material or look for stability in basic pH

It is difficult to eliminate silicones, since they float on the bath surface and are recollected by the workpiece

NB: -Cleaning time is function of contamination amount, part shape, brittleness (ultrasound), surface roughness, vessel size

- bath quality must be monitored (conductivity, pH, concentration of detergent) as frequently as the use requires it; it is effective to filter and recycle M.Taborelli, CAS-Lund, June 2017







Test of cleaning TiZrV NEG with alkaline detergent:

Presence of large amounts of silicates (up to 10%at), likely depletion of V, deterioration of activation properties:



A further test with NEG:



Clean NEG contaminated with figerprints and standard contamination (cutting oil, pump oil, bearing grease) and clean in NaOH 5M, 40C: small samples and chamber Slight V depletion (26 at% to 22 at%), some 3-4at% of Na, but perfect activation in XPS



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Pumping speed results





Ozone cleaning





Produced by UV-lamp 184.9 nm + 254 nm

 $O_2 \rightarrow O + O$ $O_2 + O \rightarrow O_3$ $O_3 \rightarrow O_2 + O^*$ (decomposition) J.R.Vig JVST A3 , 1027 (1985)

- Photolysis of hydrocarbons by UV
- Oxydation by O* and production of volatile species

- For organic contaminants
- Not for gross contamination (thick polymer layer is cross-linked rather than decomposed), is more a finishing step
- UV alone is not sufficient
- High dose can oxidise the surface (for Cu, not StSt)
- Under study for «in situ» use



Clear improvement of cleanliness in all samples:





Only detergent and solvent cleaning was discussed here, but sometimes chemical etching, electropolishing, passivationmust be used



We are using this product, is it good for cleaning parts for UHV?





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Quality control and gualification of cleaning procedures



Significant number of samples contaminated in a standardized way with representative contaminants, oils, mixtures.....

> Clean the samples with the procedure under evaluation



Analysis of sample cleanliness

Qualification in EDMS Qualification in EDMS Qualification in EDMS Compare to your application-dependent acceptance levels

Reject or accept procedure

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Cleaning of standard contaminated copper samples: air exposure =< 30 minutes



Example of evaluation of solvent effectiveness on various greases , by XPS on StSt316LN

Cleanliness analysis: FTIR

 Elution of contaminant from the "cleaned" part (tube,..) with a defined quantity of hexane per surface area
 Deposition of a drop of the resulting solution on a ZnS window (transparent to IR)
 Measurement of transmittance after evaporation of the hexane

Sensitivity to hydrocarbons an silicones: depends on the area used for the elution (various drops can be cumulated if necessary to increase concentration)

Problem: you get only what is eluted

OTher	Tech	niques
		Ingace

Auger spectroscopy (AES)	On samples. Sensitive, but carbon partly modified by beam (dose eff.)
Static SIMS	On samples. Sensitive (silicones), but difficult to quantify in general, highly sensitive
Gravimetry	On samples. Low sensitivity (we need $\sim 10^{-7}$ g/cm ²), no identification
Water contact angle	On parts, no identification, depends on surface roughness
UV fluorescence	On parts, no identification, needs calibration
UV-vis spectr, Ellipsometry	On samples through elution, hard to identify species
Optical stimulated Electron Emission, Surface potential difference	On parts, no identification of species, substrate dependent, needs calibration

ESD, PSD, ISD	On samples, sensitive, no identification (fragments)
Static outgassing rate	On parts, in acceptance tests, partial identification
TDS, TGA-MS	On samples (quartz balance for TGA, partial identification)
GC-MS, gas chromatography	On parts after elution, low sensitivity, powerful identification of large molecules
Total. Refl. X-Ray Fluoresc.	On samples, sensitive, needs mirror-like sample
Radioactive tracer	On samples, with selected contamination only

Cleaning and dynamic vacuum: Electron Stimulated Desorption test of detergents and solvents on 316LN

Memory even after 300°C bake!

Typical η (150°C) H_2 0.1CO0.02CO20.03CH40.004

See also Middleman et al. Vacuum 81, (2007) 793

Wetting and cleanliness

-Contamination has low surface energy (~25 mJ/m² for alkanes, 20 mJ/m² silicone oil, 72 mJ/m² for water, 1850 mJ/m² for Cu, 100-1000 mJ/m² for most oxides) and can adsorb easily on metallic surfaces and oxides

Hydrocarbons on stainless steel: Mantel and Wightman Surf. Interf.An. 21, 595 (1994)

-the contact angle measured after cleaning depends on cleanliness, but also on the roughness and surface reactivity to air exposure

How clean can we clean?

Start with a sputter cleaned copper (highly reactive) surface and see how fast the airborne contamination increases. Hydrocarbon re-adsorption on sputter cleaned copper surface

Trials of cleaning and keeping the sample in the rinsing water up to insertion in XPS does not improve the situation

Storage place:

Also a chemically cleaned surface is prone to re-adsorb hydrocarbons: storage in air (vertically) without protection gives similar values of carbon contamination after 4 months

Carbon evolution in 4 months storage

Cleanliness is not forever: Effect of storage in different packaging after cleaning

Aluminium foil is the best...but should not be used for copper parts , since it corrodes in presence of humidity

Storage and humidity: polyethylene bag

The PE bag is a good barrier against macroscopic contamination only

Influence of re-adsorbed contamination on SEY of copper

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Check the cleaning procedure with your cleaning plant on your own materials Design cleanable parts (shape, roughness,...)

Avoid undesirable compounds (halogens, silicones, Zn, Cd, BN...) in the fabrication process: even for the best cleaning procedure you will find them once at the end!

Avoid packaging in polymers in direct contact with the sample unless the polymer has been previously qualified.

All this will save time.

GENEVAT WORK

European Vacuum Conference 15

In Geneva – Switzerland from June 17 to June 22, 2018

THANKSYOU AND SEE YOU IN GENEN

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 R.J.Reid, Cleaning for vacuum service, CAS school on vacuum 1999, Snekkersteen M.Taborelli, CAS-Lund, June 2017
 M.Taborelli, CAS school on vacuum 2006, Platja d'Aro

A difficult case: extruded copper pipes

Copper pipes for a UHV chamber designed to receive NEG surface coating showed peel off of the coating and metallic particle residues

Amiss extrusion tool did not enable draining of the copper shavings, which remained instead incrusted on the tube's surface.

→Mechanical removal of most of the Cu particles (Cloth and hot high pressure water jet) and chemical etching of the internal surface with ammonium persulphate (about 60µm) + chromic acid passivation and rinsing

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Why is contamination stopped by aluminium foil ?

Aging is strongly retarded by packaging in metal foil (aluminium or stainless steel), which is not tight to gas

A molecule with low sticking coefficient can go very far in a small conductance. A molecule with high sticking coefficient will adsorb immediately and never reach the sample surface.

The metal foil protects from molecules with high sticking coefficient, like heavy hydrocarbons.

NB: This is strictly valid only in molecular regime, but also in viscous flow in the absence of drag (if the collisions with the gas can be "mimicked" by a reduced sticking coefficient)

Ion stimulated desorption (by N₂⁺, 2KeV): Ar desorption after Ar GD

A.Mathewson, CERN-ISR-VA/76-41 and il Vuoto vol XVII 1987, p102

CO₂ as environmental friendly solvent:

Cleaning methods: solvent

CO₂ snow: -jet spray of liquid CO₂ which condenses in solid clusters: mixture of gas and snow; by landing on the surface it builds a liquid film which dissolves contaminants

 CO₂ is non-polar, dissolves alkanes (but less effective for long chains >20) and silicones; not very effective for molecules with C=O, COOH polar groups, bad for contaminants forming drops on the surface

-to be used by keeping the workpiece warm to avoid condensation of contaminants on its surface (from environment atmosphere)

 can be used with co-solvents or soluble surfactants to dissolve polar molecules and ionic species

I elements

XPS principle

Effect on secondary electron yield

Evolution of copper SEY as a function of storage

Pumping speed results

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